



PATENT  
P56540

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

YOUNG-BIN IM *et al.*

Serial No.: 09/934,689

Examiner: ROY, SIKHA

Filed: 23 August 2001

Art Unit: 2879

For: MASK FOR COLOR CATHODE RAY TUBE, MANUFACTURING METHOD  
THEREOF AND EXPOSURE MASK FOR MANUFACTURING THE MASK

**AMENDMENT AND RESPONSE TO  
RESTRICTION REQUIREMENT**

Commissioner for Patents  
Washington, D.C. 20231

Sir:

In response to the first Office action restriction requirement mailed on 12 February 2003  
(Paper No. 4), Applicants respectfully request entry of the following amendments and remarks, re-  
examination and reconsideration for the above-captioned application.

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